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AFOSR-TR- 87-1922

Final Report

Workshop on Future Opportunites

Through GaAs on Silicon

June 18-19, 1987, Marina del Ray, CA

H. Morkoc



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The workshop was attended by about 110 researchers who are actively involved, in one phase or another, with GaAs on Si and related problems. The format of the workshop was such that there was ample opportunity for spontaneous discussions in subjects ranging from materials growth to potential systems that may be possible. The enclosed program details and the list of attendees should provide a sufficient account of what went on at the workshop.

10 June 1987

Final Detailed Program

TECHNICAL PROGRAM WORKSHOP ON FUTURE OPPORTUNITIES THROUGH GAAS ON SILICON

18-19 June 1987

Marina del Rey, California

Thursday morning: 18 June 1987

7:30-8:30 Continental Breakfast, Dining Room, Marina del Rey Marriott Hotel

8:30-9:00 Registration (Lobby, Marriott Hotel)

9:00-9:05 Welcoming Remarks: Prof. Hadis Morkoc

9:05-9:50 Plenary Session:

A. Asch, "Why GaAs/Si"

D. Shaw, "What We Have Really Accomplished"

Note: Pleanary speakers will tell us what GaAs/Si technology is all about, where we are now, where we are going and what the technology is likely to lead to if successful in application to integrated circuits and systems. They should also recount briefly the history of GaAs/Si, with reference to other lattice mismatched semiconductor materials systems, development of hetero-epitaxial materials and devices, in general, and particularly of III-V heterostructures on silicon.

SESSION I: GROWTH ISSUES:

9:50-10:10 I(a): Moderator: D. Shaw (T.I.)

"What Questions Have We Answered in GaAs/Si Epitaxy and Where are We Headed?"

- (i) Fundamental Physics of Heteroepitaxy
- (ii) Basic Limitations

Speaker: S. Wang (U.C. Berkeley)

Audience Participation

- G. Turner (Lincoln)
- T. Lee (Kopin)
- C. Itoh (FMI)
- P. Norris (GTE)

10:10-10:40 I(b): Moderator: L. Schowalter (RPI)

"Are the Present Surface Preparation Methods Adequate?"

Adequate:

Speaker: Paula Grunthaner (JPL)

- (i) Planar Growth
- (ii) For patterned growth or selective epitaxy. Thermally grown oxides (thermal desorption and chemical desorption, pseudo-in-situ removal).
- (iii) Speaker: Paula Grunthaner
 How clean the surfaces are, potential
 contamination of epi-layer during
 growth.

DISCUSSION PERIOD: 20 minutes of total time for I(b). (Directed by Moderator, assisted by speakers seated at table facing audience, next to podium.

NOTE: In each major session, the speakers together with the moderator will serve as focus of a panel discussion with audience.

Panel

- D. Biegelsen (Xerox)
- P. Grunthaner (JPL)
- F. Allen (UCLA)
- F. Grunthaner (JPL)
- D. Streit (TRW)
- L. Schowalter (RPI)

10:40-11:10 I(c): Moderator: L. Schowalter (RPI)

"Epitaxial Wafer Properties and Their Relation to

Processing/Production Issues"

Speaker: G. Turner (Lincoln Labs): (10 minutes)

MBE/MOCVD Growth as pertains to:

- (i) wafer size
- (ii) throughput, wafer cost
- (iii) compatibility with potential processing techniques
- (iv) wafer bowing, cracking, residual strain, dislocations, oval and large structural defects.

DISCUSSION PERIOD: 20 minutes of total time for I(c)

Audience

- A. Y. Cho (AT&T Bell Labs)
- C. Tu (AT&T Bell Labs)
- G. Turner (Lincoln)
- J. Lee (Kopin)
- M. Scott (Kopin)
- J. Salerno (Kopin)
- J. Posa (Crystal Spec)
- J. Fan (Kopin)
- S. Severin (UET)
- R. Lum (AT&T Holmdel)

"Growth on Patterned Wafers Selective Area Growth CaF₂/GaAs Issues"

Speaker: To be chosen by Moderator (possibly S. Wang).

11:10-11:40 Moderator: L. Schowalter (RPI)

Speakers: R. Matyi (T.I.)

J. Pinter (Ford Aerospace)

C. Tu (At&T Bell)

Issues:

- (i) Special cleaning procedures
- (ii) Special growth requirements
- (iii) Effect on hydrogen
- (iv) Effect of Ga, Al, etc. on underlying Si devices (threshold voltage shifts, etc.)
- (v) Growth over poly, SiO₂ and Si₃N₄.
- (vi) Selective etching vs. selective epitaxy.

OPEN DISCUSSION: Time allowed by Moderator

12:00-1:00 Luncheon

Thursday Afternoon

SESSION II: CHARACTERIZATION ISSUES:

1:10-1:30 II(a) Moderator: A. Jordon (AT&T)

> "Overview: Characterization Techniques Presently Employed in GaAs/Si Materials" (What are the relevant techniques and their strengths and limitations; possible new approaches needed for GaAs/Si materials.)

Speaker: Ross Briegelsen or D. Beige Isen (Xerox, PARC)

1:30-1:50 II(b) Moderator: A. Jordan (AT&T Bell)

"Structural Analysis by Transmission Electron

Microscopy"

Speaker: E. Weber and Z. Liliental-Weber

(UC Berkeley): 10 minutes

DISCUSSION PERIOD: 10 minutes of total time for II(b)

NOTE: E. Weber (Berkeley), Z. Liliental-Weber (Berkeley) and F. Ponce (Xeros) should be on panel or in the audience. Also J. H. Mazur (USC), J. Brown (AT&T), and A. E. Blackeslee (SERI).

1:50-2:00 II(c) Moderator: A. Jordan (AT&T Bell)

> "Structural Analysis by X-Ray Diffraction" Speaker: H. Zabel (University of Illinois)

> > 10 minutes

2:00-2:30 II(d): Moderator: A. Jordan (AT&T Bell)

> "Interfacial Analysis, What Can the Following Methods do for GaAs/Si Towards Devices and

Curcuits?"

STEM: "Scanning Tunneling Electron

Microscopy of GaAs/Si"

Speaker: W. Kaiser (JPL): 5 minutes

"Reflection Electron Difraction at RHEED:

GaAs/Si"

Speaker: S. Batra & P. Cohen (Univ.

of Minn.): 10 minutes

2:30-2:40 DISCUSSION PERIOD: 10 minutes of total time for II(c)

NOTE: R. Bean (Ford Aerospace), A. Macrander (AT&T), D. Neumann (NBS), and C. Sparks (Oak Ridge) should be on the panel and speak if they wish. Also J. Ahearn (Martin Marietta and C. Litton (Avionics Lab).

DISCUSSION PERIOD: During Coffee Break

2:30-3:00 Coffee Break (Coffee and Refreshments served in Classroom).

SESSION III: UNIQUE PROCESSING AND DEVICE APPROACHES:

3:00-3:20 Moderator: B. Murphy (AT&T Bell)

"Can Si Processing Lithography be Used for GaAs Devices on Si?"

Speaker: A. Saxena (RPI): 20 minutes

"Special Requirements for GaAs/Si Processing" and "Characterization of Confined Area GaAs/Si Growth" Speakers: T. Kamins/J. Adkisson, H-P Stanford 20 minutes

"Ion Implantation"

Speaker: S. Pearton (AT&T): 10 minutes

"Annealing, In-situ, Ex-situ"

Speaker: N. Chand, (AT&T): 10 minutes

OPEN DISCUSSION: Time allowed by Moderator (approx. 20 minutes)

Panel Members:

- W. Oldham (Berkeley)
- J. Salerno (Kopin)
- M. Feng (FMI)
- J. Amano (H-P)
- S. Shichijo (TI)

DISCUSSION PERIOD: Time allowed by Moderator (approx. 20 minutes)

- (i) Accomplishments to date
- (ii) Major problems
- (iii) Potential Solutions
- (iv) Eventual Limitations
- (v) Effects of defects
- (vi) Applications & reliability (Nomardi, G.E.)

Panel

- A. Y. Cho (AT&T
- H. T. Yuan (TI)
- M. Feng (iMI)
- H. K. Choi
- H. L. Hung (COMSAT)
- M. Namordi (GTE)

5:25 Break for Supper, End of Day

(Continuation of Session IV, <u>HBT's & Optical Devices</u>, Friday, morning)

Friday morning: 19 June 1987: 8:45 a.m.

SESSION IV: DISCRETE DEVICE ISSUES (continued)

IV(c): Moderator: G. Witt (AFOSR)

8:45-8:55 "HBT-type Devices"

Speaker: H. T. Yuan (TI): 10 minutes

DISCUSSION PERIOD: Time allowed by moderator (approx. 15 minutes)

"Same Issues for HBT's as for FET devices and in

addition consider:

Speaker: T. Smith/H. Huang (COMSAT): 10 min.

"Substrate Requirements"

Speaker: A. Jordan (AT&T): 10 min.

DISCUSSION PERIOD: 20 minutes of total time for V(a)

Issues:

- (i) Microwave losses
- (ii) Low substrate resistivity
- (iii) Wafer supply
- (iv) Wafer warpage
- (v) Wafer fracture strength, GaAs vs. Si.
- (vi) Substrate wafer breakage & yield
 - consideration
- (vii) Cracking of epitaxy on Si
- (viii) Cracking of epitaxy on Si
- (ix) Possible solutions through selective epitaxy and separation of device areas
- (x) Questions of thermal expansion differences

Audience/Panel

- T. Smith (COMSAT)
- H. Kim/M. Feng (FMI)
- N. Cirillo (Honeywell)
- S. Shichijo (TI)
- A. Jordan (AT&T)
- W.Tseng (NRL)
- J. King (AFWAL)
- Coffee Break 10:45-11:00
- SESSION VI: FOCUSING ON THE APPLICATIONS OF GaAs/Si IC's:
 - VI(a): Moderator: J. N. Cast (Ford Aerospace)
- 11:00-11:20 "Overview of Functional Integration for Both

Electronic and Optoelectronic IC's"

Speaker: L. Chall (Ford Aerospace): 20 minutes

HOLD DISCUSSION FOR LATER

11:20-11:30

"Integration for VLSI"
Speaker: C. Hu* (Berkeley): 10 minutes

*Will not attend

DISCUSSION PERIOD: Time allowed by Moderator (approx. 15 min.)

Experts

- L. Chall (Ford Aerospace)
- B. Murphy (AT&T)
- H. T. Yuan (T.I.)
- T. Kamins/J. Adkisson (H-P)
- A. Asch (Ford Aerospace)
- P. Ko (Berkeley)
- E. Gertner (Rockwell)
- A. Saxena (RPI)
- G. Rabanus (AFWAL)
- 11:45-1:00 BREAK FOR LUNCH (Luncheon arranged for continued discussion in hotel dining room.

Friday Afternoon

SESSION VI: FOCUSSING ON APPLICATIONS OF GaAs/Si IC's (continued):

VI(a) Moderator: J. N. Cast (Ford Aerospace)

1:00-1:15 "Impact of GaAs/Si on Si VLSI"

Speaker: A. Saxena (RPI): 15 minutes

1:15-1:35 "VLSI Design with GaAs and Si"

Speaker: B. Murphy (AT&T): 20 minutes

DISCUSSION PERIOD: Time allowed by Moderator (approx. 30 min)

VI(b) Moderator: J. N. Cast (Ford Aerospace)

1:35-1:45 "Integration for Detectors/Focal Plane Arrays" Speaker: K. Zanio (Ford Aerospace): 10 min.

1:45-1:55 "Integration for Detectors/Focal Plane Arrays" Speaker: E. Gertner (Rockwell): 10 min.

DISCUSSION PERIOD: Time allowed by Moderator (approx. 20 min.)

Expert Panel
Same members as for VI(a) above

2:00-2:20 COFFEE BREAK

SESSION VII: OPTOELECTRONIC IC'S AND OPTICAL INTERCONNECTS:

Moderator: J. C. Fan (Kopin)

2:00-2:30 VII(a) "Overview of IC's and Optical Interconnects"

Speaker: F. Leonberger (UTRC) and/or

J. Goodman (Stanford): 10 min.

2:30-2:40 VII(b) "Monolithic GaAs/Si Integration for Optical Interconnects"

Speaker: H. K. Choi (Lincoln Labs): 10 min.

OPEN DISCUSSION: Time allowed by Moderator (approx. 20 min)

Panel Members

J. Goodman (Stanford)

H. Choi (Lincoln)

J. Ballantyne (Cornell)

K. Lau (ORTEL)

A. Yariv (Caltech)

SESSION VIII: REFLECTIONS AND CLOSING REMARKS

3:00-3:30 Moderators: H. Morkoc or C. Litton

Commentary

B. Murphy

A. Saxena

T. Kamins/J. Adkisson

L. Chall

D. Shaw

3:30- FINAL ANNOUNCEMENTS, WORKSHOP CONCLUDES

GaAs/Si WORKSHOP

18-19 June 1987, Marinas del Rey, California

SESSION MODERATORS

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